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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Application Number	Not Yet Assigned
				Filing Date	Concurrently herewith
				First Named Inventor	Mikhail I. Lomaev
				Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
				Attorney Docket Number	32011-236449
Sheet	1	of	2		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/A.P./	AA*	US-6,052,401	04-18-2000	Wieser et al.	
/A.P./	AB*	US-6,400,089	06-04-2002	Salvermoser et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
/A.P./	BA	JP-5-174792	07-13-1993	Asea Brown Boveri AG		✓
	BB	JP-2002-319369	10-31-2002	Toshiba Lighting & Technology Corp.		✓
	BC	JP-2001-185089	07-06-2001	Quark Systems Kabushiki		✓
	BD	JP-11-265688	09-28-1999	Resonance Ltd.		✓
	BE	JP-5-174793	07-13-1993	Asea Brown Boveri AG		✓
/A.P./	BF	JP-2002-298790	10-11-2002	Shin'etsu Engineering Kabushiki Kaisha		✓

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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²	
/A.P./	CA	Zaidel et al., "VUV Spectroscopy", Moscow "Nauka", 1967.		
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/A.P./	CC	Tanaka "Continuous Emission Spectra of Rare Gasses in the Vacuum Ultraviolet Region", J. Opt. Soc. Am., Vol. 45, No. 9, pp. 710-713, 1955.		
	CD	Volkova et al., "VUV Irradiation Lamp" Bul. of Inventions, 1992, No. 44, p. 470.		
/A.P./	CE	Kogelschatz "Silent-Discharge Driven Excimer UV Sources and Their Applications" App. Surf. Sci., Vol. 54, pp. 410-423, 1992.		
/A.P./	CF	Salvermoser et al., "Efficient, Stable, Corona Discharge 172 nm Xenon Excimer Light Source" J. Appl. Phys., Vol. 94, No. 6, pp. 3722-3731, 2003.		
/A.P./	CG	Vollkommer et al., "Dielectric Barrier Discharge" The 8th International Symposium on Science and Technology of Light Sources LS-8, Greifswald, Germany, pp. 51-60, 1998.		
/A.P./	CH	Mildren et al., "Enhanced Performance of a Dielectric Barrier Discharge Lamp Using Short-Pulsed Excitation" J. Phys. D: Appl. Phys. Vol. 34, pp. L1-L6, 2001.		
/A.P./	CI	Esrom et al. "Metal Deposition with a Windowless VUV Excimer Source" Appl. Sur. Sci. Vol. 54, p 440, 1992.		

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Examiner Signature	/Ashok Patel/	Date Considered	04/29/2009
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